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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re the application of:

Attorney Docket No.: 2267.962US01

Charles W. Extrand

Confirmation No.: 5391

Application No.:

10/824,340

Filed:

April 14, 2004

Group Art Unit: 1724

For:

ULTRALYOPHOBIC MEMBRANE

INFORMATION DISCLOSURE STATEMENT

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Pursuant to 37 C.F.R. § 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached Form PTO-1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This information is being filed before the mailing date of a first Office Action on the merits. No certification or fee is required.

This application was filed after June 30, 2003; therefore, copies of cited U.S. patents and U.S. published applications are not included.

Respectfully submitted,

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Complete if Known Substitute for form 1449/PTO 10/824,340 Application Number **INFORMATION DISCLOSURE** Filing Date April 14, 2004 STATEMENT BY APPLICANT First Named Inventor Charles W. Extrand as many sheets as necessary) 1724 Art Unit AUG 0 1 2005 6 Examiner Name 2267.962US01 of Attorney Docket Number 7 U.S. PATENT DOCUMENTS **Publication Date EXAMINER** Cite Name of Patentee or Applicant INITIAL* No.1 Document Number MM-DD-YYYY of Cited Document Number-Kind Code^{2 (if known)} US-6,783,882 B2 Jeffrey A. Schmidt 08/31/2004 US-6,660,363 B1 12/09/2003 Wilhelm Barthlott Jefferson Yang US-6,623,882 B2 09/23/2003 US-6,605,379 B1 08/12/2003 Robert Angelo Mercuri et al. Akira Kubo et al. US-6,541,389 B1 04/01/2003 Katsuhide Shimmo et al. US-6,530,554 B2 03/11/2003 US-6,518,168 B1 02/11/2003 Paul G. Clem et al. US-6,455,021 B1 09/24/2002 Yahachi Saito US-6,444,254 B1 09/03/2002 Ashutosh Chilkoti et al. Howard Tennent et al. US-6,432,866 B1 08/13/2002 US-6,423,372 B1 07/23/2002 Jan Genzer et al. Jeffrey D. Birdsley et al. US-6,403,388 B1 07/11/2002 US-6,312,303 B1 11/06/2001 Zvi Yaniv et al. US-6,299,981 B1 Marie-Jose Azzopardi et al. 10/09/2001 George M. Whitesides et al. US-5,900,160 05/04/1999 US-5,725,788 George N. Maracas et al. 03/10/1998 US-5,679,460 10/21/1997 Josephus M. Schakenraad et al. US-5,674,592 10/07/1997 John C. Clark et al. US-5,609,907 03/11/1997 Michael Natan Charles M. Leiber et al. US-5,252,835 10/12/1993 US-5,094,749 03/10/1992 Seita et al. Fukazawa et al. US-4,909,989 03/20/1990 US-3,753,712 08/21/1973 Janneck et al. US-3,724,673 04/03/1973 Ryon US-2002/0047822 A1 03/13/2003 Masahiro Hori et al. US-2002/0150684 A1 Ahalapitiya H. Jayatissa 10/17/2002 09/26/2002 Richard E. Smalley et al. US-2002/0136683 A1

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· · ·		NON PATENT LITERATURE DOCUMENTS							
EXAMINER INITIAL*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published							
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EXAMINER INITIAL*	Cite No.1		Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published										
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